

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto HIRANO et al.

Application No.: New U.S. National Stage of PCT/JP2004/013791

Filed: March 1, 2006

Docket No.: 127194

For: SUBSTRATE TREATMENT EQUIPMENT AND MANUFACTURING METHOD OF
SUBSTRATE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.